



PATENT
Customer No. 22,852
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshio Ozawa et al.) Group Art Unit: 2823
Application No.: 09/559,757) Examiner: Pham, Thanh V.
Filed: April 27, 2000) Confirmation No. 2923
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE)
USING AN OXIDATION PROCESS)

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

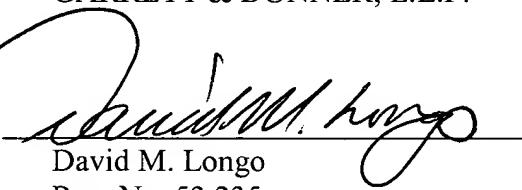
Applicants hereby petition for a one-month extension of time to reply to the Final Office Action mailed June 28, 2005. A fee of \$ 120 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By:


David M. Longo
Reg. No. 53,235

Dated: October 25, 2005

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